

Application Serial No. 10/712,921
Reply to office action of May 17, 2005

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PATENT
Docket: CU-3455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Chang Yeol LEE et al. | GRP ART UNIT: 2813
Serial No: 10/712,921 | Ex.: Chen, Jack S. J.
Filed: November 13, 2003 |
For: METHOD FOR REDUCING POLY-DEPLETION IN DUAL GATE
CMOS FABRICATION PROCESS

Certification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: September 15, 2005

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.


W. William Park, Reg. No. 55,523

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR ONE-MONTH EXTENSION OF TIME

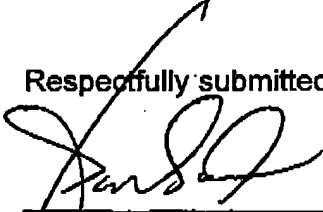
Dear Sir:

With reference to the Office Action dated May 17, 2005, Applicants hereby request a one-month extension of the term for response, which thereby extends the end date of the current term from August 17, 2005 to September 17, 2005.

Please charge \$120.00 to Deposit Account No. 12-0400 to cover the cost of the one-month extension. No other fee is believed to be required. However, if this is not the case, please charge any additional fee or credit any overpayment to the same Deposit Account No. 12-0400.

Respectfully submitted,

Dated: September 15, 2005


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